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Mark S. Habermusch

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PEARNE & GORDON LLP
1801 EAST 9TH STREET
SUITE 1200
CLEVELAND, OH 44114-3108

EXAMINER

PETTITT, JOHN F

ART UNIT

PAPER NUMBER

3744

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PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

Office Action Summary

Application No.

10/820,654

Applicant(s)

HABERBUSCH ET AL.

Examiner

/John Pettitt/

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-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

- 1) ☒ Responsive to communication(s) filed on 21 November 2007.
- 2a) ☒ This action is **FINAL**. 2b) ☐ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

- 4) ☒ Claim(s) 1-54 is/are pending in the application.
- 4a) Of the above claim(s) _____ is/are withdrawn from consideration.
- 5) ☒ Claim(s) 46-51 and 53 is/are allowed.
- 6) ☒ Claim(s) 1-11, 23-27, 32, 39-45, 52 and 54 is/are rejected.
- 7) ☒ Claim(s) 12-22, 28-31, and 33-38 is/are objected to.
- 8) ☐ Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☐ The drawing(s) filed on _____ is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.
- Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
- Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

- 12) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☐ All b) ☐ Some * c) ☐ None of:
- ☐ Certified copies of the priority documents have been received.
 - ☐ Certified copies of the priority documents have been received in Application No. _____.
 - ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

- | | |
|--|---|
| 1) <input checked="" type="checkbox"/> Notice of References Cited (PTO-892) | 4) <input type="checkbox"/> Interview Summary (PTO-413) |
| 2) <input type="checkbox"/> Notice of Draftsperson's Patent Drawing Review (PTO-948) | Paper No(s)/Mail Date. _____ |
| 3) <input type="checkbox"/> Information Disclosure Statement(s) (PTO/SB/08) | 5) <input type="checkbox"/> Notice of Informal Patent Application |
| Paper No(s)/Mail Date _____ | 6) <input type="checkbox"/> Other: _____ |

DETAILED ACTION

Drawings

1. The replacement drawings received on 03/05/2007 are accepted.

Claim Rejections - 35 USC § 112

The following is a quotation of the first paragraph of 35 U.S.C. 112:

The specification shall contain a written description of the invention, and of the manner and process of making and using it, in such full, clear, concise, and exact terms as to enable any person skilled in the art to which it pertains, or with which it is most nearly connected, to make and use the same and shall set forth the best mode contemplated by the inventor of carrying out his invention.

2. **Claims 9-10** are rejected under 35 U.S.C. 112, first paragraph, as failing to comply with the written description requirement. The claim(s) contains subject matter which was not described in the specification in such a way as to reasonably convey to one skilled in the relevant art that the inventor(s), at the time the application was filed, had possession of the claimed invention. The applicant has specifically amended claim 1 to exclude the species shown in Fig. 5 for which the subject matter of claims 9 and 10 are taught (specification paragraph 77). Therefore, claims 9-10 are inconsistent with the originally filed specification and drawings and represent new matter. Applicant's arguments are further addressed below in the response to argument section.

Claim Rejections - 35 USC § 102

3. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless –

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

4. Claims 1, 3-10, 23-24, 39-41, and 43 are rejected under 35 U.S.C. 102(b) as being anticipated by Saho et al. (US 6,332,324) hereafter Saho.

In regard to claim 1, Saho teaches a system capable of storing and delivering hydrogen comprising a liquid hydrogen storage vessel (74, 37; capable of holding hydrogen), a substantially vertically oriented orifice pulse tube refrigerator (Fig 2; 7; column 20, line 25-67), and a cooling system (thermal shields 13a and 13b and associated thermal isolation members - 40, 41, 12a, 12b) coupled to the orifice pulse tube refrigerator (7), said cooling system (13a, 13b) being adapted to counteract or abate heat transfer to the storage vessel from the ambient environment (column 3, line 25-35, 55-60; column 11, lines 40-49) and wherein no cold heat exchanger (16) of said orifice pulse tube refrigerator penetrates the liquid hydrogen storage vessel (Fig. 2 and 10); said storage vessel (74 portion of 37, 74) is capable of delivering therefrom a metered quantity (interpreted as known amount) of hydrogen (as evidenced by ability to hold helium - column 19, line 30) on demand for use as a fuel (via member 77 - Fig. 7, storage vessel capable of being used as claimed). Also storage vessel (37 portion of 74, 37) is capable of delivering therefrom a metered quantity (interpreted as a known amount) of hydrogen (as evidenced by ability to hold helium - column 10, line 36) on demand for use as a fuel (via valve - column 10, line 37-39).

In regard to claim 3, Saho teaches that the cooling system comprises a first thermal jacket (13b) exterior to and substantially enclosing said storage vessel (37, 74), and a second thermal jacket (13a) exterior to and substantially enclosing said first thermal jacket (13b).

In regard to claim 4, Saho teaches that the cooling system further comprising a super insulation material (12a, 12b) disposed around and substantially enclosing at least said storage vessel (37, 74) and said first thermal jacket (13b).

In regard to claim 5, Saho teaches that the orifice pulse tube refrigerator (7) comprises a first stage orifice pulse tube refrigeration unit (portion of 7 immediately above 24) and a second stage orifice pulse tube refrigeration unit (portion of 7 immediately above 16) that operates at a lower temperature than the first stage refrigeration unit (24; inherent to multiple staged cryocooler refrigerators such as the two stage pulse tube refrigerator disclosed; column 10, lines 57-65), said first stage refrigeration unit (24) being thermally coupled to said second thermal jacket (13a), and said second stage refrigeration unit (16) being thermally coupled to said first thermal jacket (13b).

In regard to claim 6, Saho teaches that the first stage refrigeration unit (portion of 7 immediately above 24) comprising a first stage cold heat exchanger (inherent to two stage pulse tube refrigerator - part of cooling stage 24) having a first refrigerant fluid flow passage (inherent to cooling stage 24) that is coupled to and in fluid communication with said second thermal jacket (13a), said second stage refrigeration unit (portion of 7 immediately above 16) comprising a second stage cold heat exchanger (inherent to two stage pulse tube refrigerator - part of cooling stage 16) having a second refrigerant fluid flow passage (inherent to cooling stage 16) that is coupled to and in fluid communication with said first thermal jacket (13b), wherein a first refrigerant fluid (helium at first stage temperature; column 10, line 5), refrigerated at said

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first stage cold heat exchanger to a first temperature (capable of 50 K - column 5, line 62), is circulated through said second thermal jacket (13a) during operation of said system, and wherein a second refrigerant fluid (helium at first stage temperature; column 10, line 5), refrigerated at said second stage cold heat exchanger to a second temperature (capable of 7 K - column 5, line 62), is circulated through said first thermal jacket (13b) during operation of said system.

In regard to claim 7, Saho teaches that the system is capable of operating with the first temperature of 60-100K.

In regard to claim 8, Saho teaches that the system is capable of operating at the second temperature of 13-20K.

In regard to claim 9, Saho teaches that said cooling system comprises a heat transfer body (29) projecting directly into a hydrogen storage volume (37) of said storage vessel (74, 37; from cooling plate 41), said heat transfer body (29) being thermally coupled to said orifice pulse tube refrigerator (through Cooling plate 41).

In regard to claim 10, Saho teaches that the heat transfer body comprises a heat transfer fin (29).

In regard to claim 23, Saho teaches an outer housing (6) defining a primary vacuum chamber therein (38), said liquid hydrogen storage vessel (37 or 74) and said cooling system (thermal shields 13a and 13b and associated thermal isolation members - 40, 41, 12a, 12b) being disposed within said primary vacuum chamber (38).

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In regard to claim 24, Saho teaches that the operative cold components of said orifice pulse tube refrigeration unit (7) are disposed within said primary vacuum chamber (38).

In regard to claim 39, Saho teaches that the system is capable of maintaining liquid hydrogen in said storage vessel (37, 74) at or below 20K at steady state, such that substantially no venting of vaporized hydrogen is necessary to relieve hydrogen overpressure within the vessel (37; column 3, lines 1-14, 33-35; column 19, line 56).

In regard to claim 40, Saho teaches an oscillatory gas pressure power source (20) coupled to said orifice pulse tube refrigerator (7), said oscillatory gas pressure power source (20) being adapted to provide periodic pressure surges in a working fluid to drive said orifice pulse tube refrigerator (7) to thereby generate refrigeration power (inherent to orifice pulse tube refrigerators).

In regard to claim 41, Saho teaches that the oscillatory gas pressure power source being an electric gas compressor (column 6, lines 17-21).

In regard to claim 43, Saho teaches that the orifice pulse tube refrigerator (7) comprising a first stage orifice pulse tube refrigeration unit (portion of 7 immediately above 24) and a second stage orifice pulse tube refrigeration unit (portion of 7 immediately above 16), each of the first and second stage refrigeration units (inherently) comprise a respective regenerator, cold heat exchanger, pulse tube and hot heat exchanger, wherein net refrigeration power for each of the first and second stage refrigeration units is generated respectively at the first stage cold heat exchanger and the second stage cold heat exchanger.

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5. **Claim 1** is rejected under 35 U.S.C. 102(b) as being anticipated by Stautner et al. (US 6,192,690) hereafter Stautner. Stautner teaches a system capable of storing and delivering hydrogen comprising a liquid hydrogen storage vessel (3 or 16 - inner vessel hereafter simply 3; column 1, lines 17-27), a substantially vertically oriented orifice pulse tube refrigerator (32), and a cooling system (radiation shields) coupled to the orifice pulse tube refrigerator (32), said cooling system (radiation shields) being adapted to counteract or abate heat transfer to the storage vessel (16; column 1, lines 17-27) from the ambient environment and wherein no cold heat exchanger of said orifice pulse tube refrigerator (32) penetrates the liquid hydrogen storage vessel (3); said storage vessel (3) is capable of delivering therefrom a metered quantity (interpreted as a known amount) of hydrogen (as evidenced by ability to hold helium - column 3, lines 9-12; and able to emit the hydrogen through tubes at top of apparatus - Figure 1) on demand for use as a fuel (capable of being used as claimed).

6. **Claim 1** is rejected under 35 U.S.C. 102(b) as being anticipated by Inoue et al. (US 5,966,944) hereafter Inoue. Inoue teaches a system capable of storing and delivering hydrogen comprising a liquid hydrogen storage vessel (3), a substantially vertically oriented orifice pulse tube refrigerator (7), and a cooling system (liquid nitrogen-5 and vacuum vessel -1) coupled to the orifice pulse tube refrigerator (7), said cooling system (liquid nitrogen-5 and vacuum vessel -1) being adapted to counteract or abate heat transfer to the storage vessel (3) from the ambient environment and wherein no cold heat exchanger of said orifice pulse tube refrigerator (7) penetrates the liquid

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hydrogen storage vessel refrigerator (Figure 3) penetrates the liquid hydrogen storage vessel (3). The storage vessel (3) is capable of delivering therefrom a metered quantity (interpreted as a known amount) of hydrogen (as evidenced by ability to hold helium) on demand for use as a fuel (via tubes at top of figure 2).

7. **Claims 2, 23-24, and 26** are rejected under 35 U.S.C. 102(b) as being anticipated by Laskaris et al. (US 6,438,969) hereafter Laskaris (969).

In regard to claim 2, Laskaris (969) teaches a system capable of storing and delivering hydrogen comprising a liquid hydrogen storage vessel (38; Figure 2) in the shape of a hollow toroid (Fig. 2) having an interior surface (interior of tubing 38) that defines a hydrogen storage volume of the storage vessel (38), a substantially vertically oriented orifice pulse tube refrigerator (72), and a cooling system (60, 70, 66, 52, 56, 64, 62, 10) coupled to the orifice pulse tube refrigerator (72), said cooling system being adapted to counteract or abate heat transfer to the storage vessel (which is within 10) from the ambient environment.

In regard to claim 23, Laskaris (969) teaches an outer housing (56) defining a primary vacuum chamber therein (column 4, lines 52; column 6, lines 29-42), said liquid hydrogen storage vessel (60) and said cooling system (66, 70, 62) being disposed within said primary vacuum chamber (within 56).

In regard to claim 24, Laskaris (969) teaches that the operative cold components of said orifice pulse tube refrigeration unit (72) are disposed within said primary vacuum chamber (within 56).

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In regard to claim 26, Laskaris (969) teaches that said housing (56) further defining a secondary chamber (lower side portion of 56 is part of further defining secondary chamber 16 within 10; column 3, lines 41-42), separate and apart from said primary vacuum chamber (within 56), said system further comprising relatively high temperature hydrogen conditioning equipment (coil-36, tubing 38; capable of conditioning hydrogen to increase the hydrogen's temperature) disposed within said secondary chamber (16).

Claim Rejections - 35 USC § 103

8. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

The factual inquiries set forth in *Graham v. John Deere Co.*, 383 U.S. 1, 148 USPQ 459 (1966), that are applied for establishing a background for determining obviousness under 35 U.S.C. 103(a) are summarized as follows:

1. Determining the scope and contents of the prior art.
2. Ascertaining the differences between the prior art and the claims at issue.
3. Resolving the level of ordinary skill in the pertinent art.
4. Considering objective evidence present in the application indicating obviousness or nonobviousness.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein

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were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

9. **Claim 44** is rejected under 35 U.S.C. 103(a) as being unpatentable over the obvious modification of Saho. Saho teaches that the two stage orifice pulse tube refrigerator is capable of being operated at steady state with said first stage cold heat exchanger operating at 60-100K and said second stage cold heat exchanger operating at 13-20K. Saho does not teach what refrigeration power is provided for the various temperature ranges that the first and second stages are capable of operating at; however, Saho is designed to provide cooling to a variety of superconducting electronics. Depending on the size of the electronics the orifice pulse tube refrigerator would necessarily be designed or selected to meet the required heat load from the electronics (and any remaining heat leak from the environment). One of ordinary skill in the art would know how to appropriately design and select a two-stage pulse tube refrigerator that would be capable of supplying 4-6 Watts of refrigeration at the superconducting temperatures of interest and would be motivated to do so in order to efficiently maintain the cryogenic temperature of the" electronics. Therefore, it would have been obvious to one of ordinary skill in the art, at the time the invention was made, to employ a two-stage orifice pulse tube refrigerator that is capable of providing 4-6

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Watts of refrigeration at the temperatures desired for the purpose of maintaining proper operation of the superconducting electronics.

10. Claims 11 and 32 are rejected under 35 U.S.C. 103(a) as being unpatentable over Saho in view of C. Wang et al. (Cryogenics, 1997, Vol. 37, Issue 12, p. 857- 863) and Wang (US 6,378,312).

In regard to claim 11, Saho teaches all of the limitations of claim 1 and further discloses an oscillatory gas pressure power source (20; inherent to orifice pulse tube refrigerators) coupled to said orifice pulse tube refrigerator (7) via a transfer tube (23b), said orifice pulse tube refrigerator comprising a first stage orifice pulse tube refrigeration unit (portion of 7 immediately above 24) and a second stage orifice pulse tube refrigeration unit (portion of 7 immediately above 16), but Saho does not explicitly teach the specific components of the two stage orifice pulse tube refrigerator (7).

However, Wang et al. (p.857) teach a high performing two-stage orifice pulse tube refrigerator (Figure 1(d)) capable of operating at the temperatures of the Saho system. Wang et al. (p.857) teach that each of the first and second stage (Figure 1(d)) refrigeration units comprise a respective regenerator (12 and 13), cold heat exchanger (17 and 20), pulse tube (16 and 19), hot heat exchanger (15 and 18), primary orifice (5 and 7), inertance tube (8 and 11) and reservoir volume (9 and 10), and each stage having a second orifice (4 and 6 or alternatively 5 and 7 can act as primary and secondary valves) connecting the respective hot heat exchanger to the transfer tube (line extending from 2).

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Further, Wang (p.857) teaches that his disclosed two-stage orifice pulse tube refrigerator is highly efficient, has high reliability, and low vibrations and production cost (page 857, column 2). Therefore, it would have been obvious to one of ordinary skill in the art, at the time the invention was made, to employ the two stage orifice pulse tube refrigerator of Wang (p.857) in the cryostat of Saho for the purpose of providing an efficient, reliable, low cost refrigerator for system.

In regard to claim 32, Saho teaches all of the limitations of claim 1 and further disclose a first stage orifice pulse tube refrigeration unit (portion of 7 immediately above 24) and a second stage orifice pulse tube refrigeration unit (portion of 7 immediately above 16) that operates at a lower temperature than the first stage refrigeration unit (inherent to staged orifice pulse tube refrigerators), but Saho does not explicitly teach the specific components of the two stage orifice pulse tube refrigerator (7).

However, Wang et al. (p.857) teach a high performing two-stage orifice pulse tube refrigerator (Figure I(d)) capable of operating at the temperatures of the Saho system. Wang et al. (p.857) teach that each of the first and second stage (Figure I(d)) refrigeration units comprise a respective regenerator (12 and 13), cold heat exchanger (17 and 20), pulse tube (16 and 19), hot heat exchanger (15 and 18), said second stage regenerator (13) having a second heat absorptive material therein (regenerator is layered with three layers, lead meets the criteria below), said second heat absorptive material having a volumetric heat capacity of at least $0.23 \text{ J/cm}^3\text{K}$ at 13-14K, a volumetric heat capacity of at least $0.5 \text{ J/cm}^3\text{K}$ at 18-20K (support that this information is implicit, see "Numerical analysis of 4K pulse tube coolers: Part I. Numerical

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Simulation", Cryogenics, C. Wang, 1997, Vol. 37, issue 4, Figure 3), and a porosity of 0.2-0.5 (implicitly taught; proven by porosity taught in C. Wang, Vol. 37, issue 4, p.211, 2nd paragraph).

Further, Wang (p.857) teaches that his disclosed two-stage orifice pulse tube refrigerator is highly efficient, has high reliability, and low vibrations and production cost (page 857, column 2). Therefore, it would have been obvious to one of ordinary skill in the art, at the time the invention was made, to employ the two stage orifice pulse tube refrigerator of Wang (p.857) in the cryostat of Saho for the purpose of providing an efficient, reliable, low cost refrigerator for system.

11. Claim 25 is rejected under 35 U.S.C. 103(a) as being unpatentable over Saho in view of Rampersad et al. (US 6,640,552) hereafter Rampersad. Saho teaches all of the limitations of claim 24 but does not disclose what pressure the vacuum of the primary chamber is maintained at. However, it is well known in the art that vacuum insulation is maintained at less than 10^{-4} Torr as taught by Rampersad (column 2, line 50) for the purpose of providing thermal insulation. Therefore, it would have been obvious to one of ordinary skill in the art, at the time the invention was made, to employ a vacuum of less than 10^{-2} Torr for the purpose of insulating the components within the primary chamber from ambient heat leak.

12. Claim 25 is rejected under 35 U.S.C. 103(a) as being unpatentable over Laskaris (969) in view of Rampersad. Laskaris (969) teaches all of the limitations of claim 24 but

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does not disclose what pressure the vacuum of the primary chamber is maintained at. However, it is well known in the art that vacuum insulation is maintained at less than 10^{-4} Torr as taught by Rampersad (column 2, line 50) for the purpose of providing thermal insulation. Therefore, it would have been obvious to one of ordinary skill in the art, at the time the invention was made, to employ a vacuum of less than 10^{-2} Torr for the purpose of insulating the components within the primary chamber from ambient heat leak.

13. Claim 27 is rejected under 35 U.S.C. 103(a) as being unpatentable over Laskaris (969) in view of Rampersad. Laskaris (969) teaches all the limitations of claim 26 but does not disclose what pressure the vacuum of the secondary chamber is maintained at. However, it is well known in the art that vacuum insulation is maintained at less than 10^{-2} Torr as taught by Rampersad (column 2, line 50) for the purpose of providing thermal insulation. Therefore, it would have been obvious to one of ordinary skill in the art, at the time the invention was made, to employ a vacuum of less than 10^{-2} Torr for the purpose of insulating the components within the secondary chamber from ambient heat leak.

14. Claim 42 is rejected under 35 U.S.C. 103(a) as being unpatentable over Saho in view of Foster et al. ("Development of a High Capacity Two-Stage Pulse Tube Cryocooler", Cryocoolers 12, March 1, 2003, p.225-232). Saho does not explicitly teach that the compressor employed for the pulse tube refrigerator has a linear drive and flexure bearings. However, Foster teaches a linear drive flexure bearing compressor (p.

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232, paragraph 2, p. 225 - abstract and introduction) are robust, provide good reliability, and low vibrations with an overall low mass. Therefore, it would have been obvious to one of ordinary skill in the art, at the time the invention was made, to modify the refrigerator of Saho with the linear drive flexure bearing compressor of Foster to improve the reliability and lower the mass of the overall system.

15. Claim 45 is rejected under 35 U.S.C. 103(a) as being unpatentable over Saho in view of Peschka et al. (US 4,608,830) hereafter Peschka. Saho teaches a cryostat capable of significantly reducing boil off of stored cryogen via active refrigeration in the form of a two stage orifice pulse tube refrigerator as claimed in claim 1, but does not teach an automobile comprising a hydrogen-powered internal combustion engine. However, hydrogen powered automobiles are well known in the art, as for example taught by Peschka. Peschka teaches an automobile (1) comprising a hydrogen-powered internal combustion engine (motor). Therefore, it would have been obvious to one of ordinary skill in the art, at the time the invention was made, to combine the cryostat system of Saho in the liquid Hydrogen (LH2) powered automobile taught by Peschka for the purpose of maintaining the cryogenic fuel and preventing the fuel from being wasted.

16. Claim 52 is rejected under 35 U.S.C. 103(a) as being unpatentable over Saho in view of Haberbusch et al. (US 6,431,750) hereafter Haberbusch. Saho teaches all the limitations of claim 1 but does not explicitly teach a liquid level probe comprising

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adhered flexible dielectric strips and a series of temperature sensor disposed at spaced intervals along the length of the probe. However, it is common in the art to employ a liquid level sensor within cryogen storage volumes for the purpose of determining the amount of cryogen with the storage volume. In addition, Habermusch teaches a liquid level probe (20) comprising adhered flexible dielectric strips (40) and a series of temperature sensors (22) disposed at spaced intervals along the length of the probe (20) useful for determining the level of cryogenic liquid within a storage volume.

Therefore, it would have been obvious to one of ordinary skill in the art, at the time the invention was made, to modify the system of Saho by installing the liquid level sensor of Habermusch within the storage vessel (37) for the purpose of providing a convenient means of determining the liquid level of the storage vessel (37).

17. Claim 52 is rejected under 35 U.S.C. 103(a) as being unpatentable over Laskaris (969) in view of Habermusch. Laskaris (969) teaches all the limitations of claim 1 but does not explicitly teach a liquid level probe comprising adhered flexible dielectric strips and a series of temperature sensor disposed at spaced intervals along the length of the probe. However, it is common in the art to employ a liquid level sensor within cryogen storage volumes for the purpose of determining the amount of cryogen with the storage volume. Habermusch teaches a liquid level probe (20) comprising adhered flexible dielectric strips (40) and a series of temperature sensors (22) disposed at spaced intervals along the length of the probe (20) useful for determining the level of cryogenic liquid within a storage volume. Therefore, it would have been obvious to one of ordinary

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skill in the art, at the time the invention was made, to modify the system of Laskaris (969) by installing the liquid level sensor of Haberbusch within the storage vessel (60) for the purpose of providing a convenient means of determining the liquid level of the storage vessel.

18. Claim 54 is rejected under 35 U.S.C. 103(a) as being unpatentable over Inoue in view of Class et al. (US 2,937,076). Inoue teaches all of the limitations of claim 54 but does not teach equipment for conditioning hydrogen from the storage vessel and to provide conditioned hydrogen in a suitable state for delivery to an engine or fuel cell that consumes said conditioned hydrogen as fuel. However, when hydrogen is used as the cryogenic liquid to cool the superconducting apparatus of Inoue during some periods of operation some of the liquid will be vaporized and leave through the tubes at the top of the cryostat. Rather than venting this valuable gas to the atmosphere one could send the vapor to a system such as that of Class for the purpose of storing and retaining the hydrogen for further use. Therefore, it would have been obvious to one of ordinary skill in the art, at the time the invention was made, to modify Inoue to have the hydrogen conditioning equipment of Class for the purpose of saving the hydrogen vapor rather than vent this valuable commodity to the atmosphere.

Allowable Subject Matter

19. **Claim 46-51 and 53** are allowed.
20. **Claims 12-22, 28-31, and 33-38** are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

Response to Arguments

21. Applicant's arguments filed 8/28/07 have been fully considered and while the applicant's arguments are found to be cogent they are not fully persuasive.

1. Applicant's arguments (page 12, paragraph 3) are that claim 49 is dependent from claim 46 previously allowed and is therefore properly rejoined. In response to the applicant's arguments, the examiner rejoins claim 49 and allows claim 49 as being dependent from an allowable claim.

2. In response to the applicant's reminder (page 12, paragraph 4) concerning Figure 5, Figure 5 is accepted as stated above.

3. Applicant's arguments (page 12, paragraph 5 - page 13, paragraph 1) are that claim 9 does not present new matter because of the description of the invention found in paragraph 77 of the applicant's specification. In response to the applicant's arguments, the examiner disagrees that the specification supports the claimed subject matter. First, the citation quoted by the applicant is a description of the embodiment shown in Figure 5, which clearly shows that the cold heat exchanger (292) of the pulse tube refrigerator is penetrating into the liquid hydrogen storage space (5). This quality is positively excluded by claim 1; therefore, the applicant cannot reasonably submit that the

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description of the structure of Figure 5 supports a fin protruding into the storage space while the cold heat exchanger is not protruding into the hydrogen storage space. Hence, the rejection of claims 9-10 under 35 U.S.C. § 112 first paragraph is maintained.

4. Applicant's arguments (page 12, paragraph 2 - page 14) are that the prior art of record does not teach all the limitations of claim 1, as amended (claim 1, lines 4-6); specifically, that the vessel cited by the examiner in all of the prior art is not "adapted to deliver therefrom a metered quantity of hydrogen on demand for use as a fuel". In response to the applicant's arguments, the examiner fully disagrees for the following reasons.

First, the amended limitation, only limits how the vessel is used. Such functional language may only limit an apparatus claim insofar as to require that the apparatus is capable of the function. The structural requirements of the quoted limitation are broadly and reasonably interpreted to mean that hydrogen can be withdrawn from said vessel, and that said withdrawn hydrogen may be used as fuel (an inherent property of hydrogen). To argue that hydrogen must be within the vessel for the claim limitation to be met would lead to the conclusion that the system would only be infringed when the storage vessel was filled with hydrogen.

Second, the applicant's allegation that none of the references teach that hydrogen is a known coolant for superconductive devices, is unfounded, as the examiner directs the applicant to Laskaris (969) column 5, line 42 and 49; further (and more importantly) the claims only require that the structure of the system is capable of having hydrogen within the vessel.

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Finally, it is noted that for references such as Stautner and Inoue, the cryostats are designed for allowing vapor to escape from the storage vessel, therefore, arguments that hydrogen cannot be removed and employed are unpersuasive.

5. Applicant's arguments (page 14, ¶ 5 - page 15) are that the cited storage vessel cannot be construed as a storage vessel because it is formed from a tube. In response to the applicant's arguments, the examiner fully disagrees, the broadest reasonable interpretation of the limitation "hydrogen storage vessel" is a means that can hold hydrogen, not that the vessel must have hydrogen therein with no circulation. Certainly, large differently shaped containers capable of holding hydrogen are no less "storage vessels" when no hydrogen is within them or if hydrogen is added and removed from them simultaneously. Further, if during operation of Laskaris the flow of hydrogen were to periodically stop, the hydrogen within vessel (38) would then be temporarily "stored"; therefore, regardless, the structure of the cited art meets the claimed limitations. Arguments about how the volume within vessel (38) is used are not persuasive and the rejection is maintained.

Conclusion

22. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire **THREE MONTHS** from the mailing date of this action. In the event a first reply is filed within **TWO MONTHS** of the mailing date of this final action and the advisory action is not mailed until after the end of the **THREE-MONTH** shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than **SIX MONTHS** from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to /John Pettitt/ whose telephone number is 571-272-0771. The examiner can normally be reached on M-F 8a-4p.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Cheryl Tyler can be reached on 571-272-4834. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR.

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/John Pettitt/
Examiner
Art Unit 3744
JFP III
January 31, 2008


CHERYL TYLER
SUPERVISORY PATENT EXAMINER